

MS PETITION
PATENT
1028-0171P

IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant: LEDOUX, et al. Conf.: 7224
Appl. No.: 09/822,864 Group: 2881
Filed: April 2, 2001 Examiner: K.T. NGUYEN
For: METHOD AND SYSTEM FOR CONTROLLING BEAM
SCANNING IN AN ION IMPLANTATION DEVICE

LETTER SUBMITTING COPY OF
PETITION TO WITHDRAW THE HOLDING OF ABANDONMENT
ORIGINALLY FILED ON FEBRUARY 17, 2004

MS PETITION
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

June 23, 2004

Sir:

As per our telephone conference with Petition Attorney D. Woods, attached hereto is a copy of a Petition to Withdraw the Holding of Abandonment and its enclosures as filed on February 17, 2004. Additionally, attached hereto is a postcard stamped by the U.S. Patent and Trademark Office acknowledging receipt of the Petition as mentioned above.

It is respectfully requested that the U.S. Patent and Trademark Office withdraw the improper holding of abandonment and issue the present application as per the Petition filed on February 17, 2004.

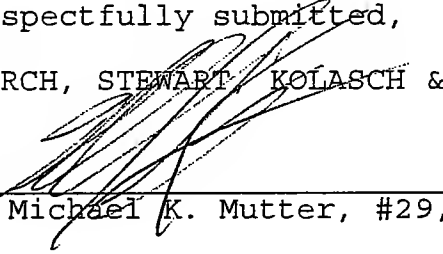
It is submitted that no fees are required for filing this Petition, since the error occurred because of a mistake on the part of the U.S. Patent and Trademark Office.

If necessary, the Commissioner is hereby authorized in this, concurrent, and future replies, to charge payment or credit any overpayment to Deposit Account No. 02-2448 for any additional fee required under 37 C.F.R. §§ 1.16 or 1.17; particularly, extension of time fees.

Respectfully submitted,

BIRCH, STEWART, KOLASCH & BIRCH, LLP

By


Michael K. Mutter, #29,680

MKM/apw
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P.O. Box 747
Falls Church, VA 22040-0747
(703) 205-8000